

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Hayashi et al.
Appl. No.	:	10/561,830
Filed	:	December 22, 2005
For	:	POSITIVE RESIST COMPOSITION AND METHOD OF FORMING RESIST PATTERN USING SAME
Examiner	:	Eoff, Anca
Group Art Unit	:	1795

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed **February 2, 2010**, please consider the following amendments and remarks:

Amendments to the claims are reflected in **the listing of claims** which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.